

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hojo et al.
Appl. No. : 10/553,083
Filed : October 11, 2005
For : POSITIVE RESIST
COMPOSITION AND METHOD
OF FORMATION OF RESIST
PATTERN
Examiner : C. Hamilton
Group Art Unit : 1752

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed July 3, 2007, Applicants respectfully request the Examiner to enter the following amendments and consider the following remarks.

The listing of claims begins on page 2 of this paper. The claims are provided for the Examiner's convenience. No amendments have been made.

Remarks begin on page 5 of this paper.